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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Case No. 213.007-US)

In the Application of: Ye et al.

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Serial No: 10/815,573

)

U.S. Patent 7,003,758

Filed: April 1, 2004

)

Title: System and Method of Lithography
Simulation

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Michael Sitar

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Michael Sitar

Signature

NOTIFICATION OF CHANGE OF SMALL ENTITY STATUS

Dear Sir:

Pursuant to 37 CFR §1.27(g)(2), the above-referenced patent/application is no
longer entitled to small entity status.

Respectfully submitted,



Neil A. Steinberg, Reg. No. 34,735
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Date: April 19, 2007